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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet 1 of 2

Complete if Known	
Application Number	
Filing Date	
First Named Inventor	Constantine P. GRIGOROPOULOS
Group Art Unit	
Examiner Name	
Attorney Docket Number	UCB-6(B01-108)

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No.[1]	U.S. Patent Document: Number	U.S. Patent Document: Kind Code[2] (if known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant, Passages or Relevant Figures Appear or Class/Subclass
	AA.	6,331,056		Nohr et al	Dec. 18, 2001	347/102
	AB.	5,391,841		Quick	Feb. 21, 1995	174/258
	AC.	4,910,118		Adair et al	March 20, 1990	430/138

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No.[1]	Foreign Patent Document: Office[3]	Foreign Patent Document: Number[4]	Foreign Patent Document: Kind Code[5] (if known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant, Passages or Relevant Figures Appear	T[6]
	AD.	EP	0 417 294			March 20, 1991		
	AE.	JP	2000-104101	(with English-abstract)		April 11, 2000		
	AF.	JP	11-350107	(with English-abstract)		Dec. 21, 1999		
	AG.	WO	00/10197			Feb. 24, 2000		
	AH.	WO	99/53738	(with English-abstract)		Oct. 21, 1999		

Examiner Signature		Date Considered	

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

[1] Unique citation designation number. [2] See attached Kinds of U.S. Patent Documents. [3] Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). [4] For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. [5] Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. [6] Applicant is to place a check mark here if English language Translation is attached.

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet 2 of 2

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Application Number	
Filing Date	
First Named Inventor	Constantine P.
Group Art Unit	
Examiner Name	
Attorney Docket Number	UCB-6(B01-108)

OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.[1]	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T[2]
	AI.	N.R. Bieri et al, "Microstructuring by printing and laser curing of nanoparticle solutions", Applied Physics Letters, Vol. 82, No. 20, 19 May 2003, pp. 3529-3531.	
	AJ.	N.R. Bieri et al, "Manufacturing of Electrically Conductive Microstructures by Dropwise Printing and Laser Curing of Nanoparticle-Suspensions", Proceedings of IMECE2002, ASME International Mechanical Engineering Congress & Exposition, (© 2002 ASME), November 17-22, 2002, New Orleans, Louisiana, pp. 1-8.	
	AK.	D.B. Bogy et al, "Experimental and Theoretical Study of Wave Propagation Phenomena in Drop-on-Demand Ink Jet Devices", IBM J. Res. Develop., Vol. 28, No. 3, May 1984, pp. 314-321.	
	AL.	Ph. Buffat et al, "Size effect on the melting temperature of gold particles", Physical Review A, Vol. 13, No. 6, June 1976, pp. 2287-2298.	
	AM.	J.F. Dijksman, "Hydrodynamics of small tubular pumps", J. Fluid Mech. (1984), Vol. 139, pp. 173-191.	
	AN.	Sawyer Fuller et al, "Ink Jet Fabricated Nanoparticle Mems", Proceedings IEEE 13th Annual International Conference of Micro Electro Mechanical Systems IEEE 2000, Piscataway, NJ (© 2000 IEEE), pp. 138-141.	
	AO.	Sawyer B. Fuller et al, "Ink-Jet Printed Nanoparticle Microelectromechanical Systems", Journal of Microelectromechanical Systems, Vol. 11, No. 1, February 2002 (© 2002 IEEE), pp. 54-60.	
	AP.	G.V. Shivashankar et al, "Biomolecular recognition using submicron laser lithography", Applied Physics Letters, Vol. 73, No. 3, 20 July 1998 (© 1998 American Institute of Physics), pp. 417-427.	
	AQ.	John B. Szczech et al, "Fine-Line Conductor Manufacturing Using Drop-On-Demand PZT Printing Technology", IEEE Transactions on Electronics Packaging Manufacturing, Vol. 25, No. 1, January 2002 (© 2002 IEEE), pp. 26 33.	

Examiner Signature		Date Considered	

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[1] Unique citation designation number. [2] Applicant is to place a check mark here if English language Translation is attached.

IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE

PATENT APPLICATION

Applicants: **Constantine P. GRIGOROPOULOS,**
Nicole Reneé BIERI,
Dimos POULIKAKOS,
Jaewon CHUNG

Atty. Doc.: **UCB-6(B01-108)**

Serial No.: Filed:

Group Art Unit: Confirmation No.:

Examiner:

Title: **A METHOD FOR PRODUCING A STRUCTURE USING NANOPARTICLES**

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

S I R:

DISCLOSURE STATEMENT

The applicants respectfully request that the following references be considered in the examination of the above-identified application. A copy of each reference is enclosed.

United States Patents

Patent Number	Inventor	Date Issued	Class
AA. 6,331,056	Nohr et al	Dec. 18, 2001	347/102
AB. 5,391,841	Quick	Feb. 21, 1995	174/258
AC. 4,910,118	Adair et al	March 20, 1990	430/138

European Published Patent Application

Publication No.	Publication Date
AD. 0 417 294	March 20, 1991

Japanese Published Patent Applications

Publication No.	Publication Date
AE. 2000-104101	April 11, 2000
AF. 11-350107	Dec. 21, 1999

International Published Patent Applications

Publication No.	Publication Date
AG. WO 00/10197	Feb. 24, 2000
AH. WO 99/53738	Oct. 21, 1999

Publications

AI. N.R. Bieri et al, "Microstructuring by printing and laser curing of nanoparticle solutions", Applied Physics Letters, Vol. 82, No. 20, 19 May 2003, pp. 3529-3531.

AJ. N.R. Bieri et al, "Manufacturing of Electrically Conductive Microstructures by Dropwise Printing and Laser Curing of Nanoparticle-Suspensions", Proceedings of IMECE2002, ASME International Mechanical Engineering Congress & Exposition, (© 2002 ASME), November 17-22, 2002, New Orleans, Louisiana, pp. 1-8.

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AL. Ph. Buffat et al, "Size effect on the melting temperature of gold particles", Physical Review A, Vol. 13, No. 6, June 1976, pp. 2287-2298.

AM. J.F. Dijksman, "Hydrodynamics of small tubular pumps", J. Fluid Mech. (1984), Vol. 139, pp. 173-191.

AN. Sawyer Fuller et al, "Ink Jet Fabricated Nanoparticle Mems", Proceedings IEEE 13th Annual International Conference of Micro Electro Mechanical Systems IEEE 2000, Piscataway, NJ (© 2000 IEEE), pp. 138-141.

AO. Sawyer B. Fuller et al, "Ink-Jet Printed Nanoparticle Microelectromechanical Systems", Journal of Microelectromechanical Systems, Vol. 11, No. 1, February 2002 (© 2002 IEEE), pp. 54-60.

AP. G.V. Shivashankar et al, "Biomolecular recognition using submicron laser lithography", Applied Physics Letters, Vol. 73, No. 3, 20 July 1998 (© 1998 American Institute of Physics), pp. 417-427.

AQ. John B. Szczech et al, "Fine-Line Conductor Manufacturing Using Drop-On-Demand PZT Printing Technology", IEEE Transactions on Electronics Packaging Manufacturing, Vol. 25, No. 1, January 2002 (© 2002 IEEE), pp. 26-33.

REMARKS

Under rule 37 C.F.R. 1.98(a) (effective March 16, 1992), since the above-cited references (AA-AD, AG and AI-AQ) are in the English language, the applicants submit that no specific comments are necessary for any of these. An English-language abstract accompanies References AE, AF and AH.

For the Examiner's convenience, the applicants have attached a completed modified Form PTO/SB/08A-B hereto.

Respectfully submitted,

July 15, 2003

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